

Form PTO-1449

Docket Number 511582001621

Application Number 10/010,667

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Applicant AFAR, et al.

Filing Date 6 December 2001

Group Art Unit 1642

Mailing Date January 23 2003

U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate
GW	1.	21-Feb-02	US2002022248-A1	Xu et al.	—	—	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO
	2.	22-Jun-99	JP11164691-A	Japan			X
GW	3.	27-Jan-00	WO200004149-A2	WIPO			
	4.	21-Dec-00	WO200077021-A1	WIPO			
	5.	12-Apr-01	WO200125272-A2	WIPO			
	6.	17-May-01	WO200134802-A2	WIPO			
	7.	7-Jun-01	WO200140276-A2	WIPO			
	8.	19-Jul-01	WO200151633-A2	WIPO			
	9.	9-Aug-01	WO200157190-A2	WIPO			
	10.	9-Aug-01	WO200157276-A2	WIPO			
	11.	9-Aug-01	WO200157277-A2	WIPO			
	12.	23-Aug-01	WO200160860-A2	WIPO			
	13.	4-Oct-01	WO200173032-A2	WIPO			

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